

FIG 1: PLASMA SPUTTER DEPOSITION SYSTEM

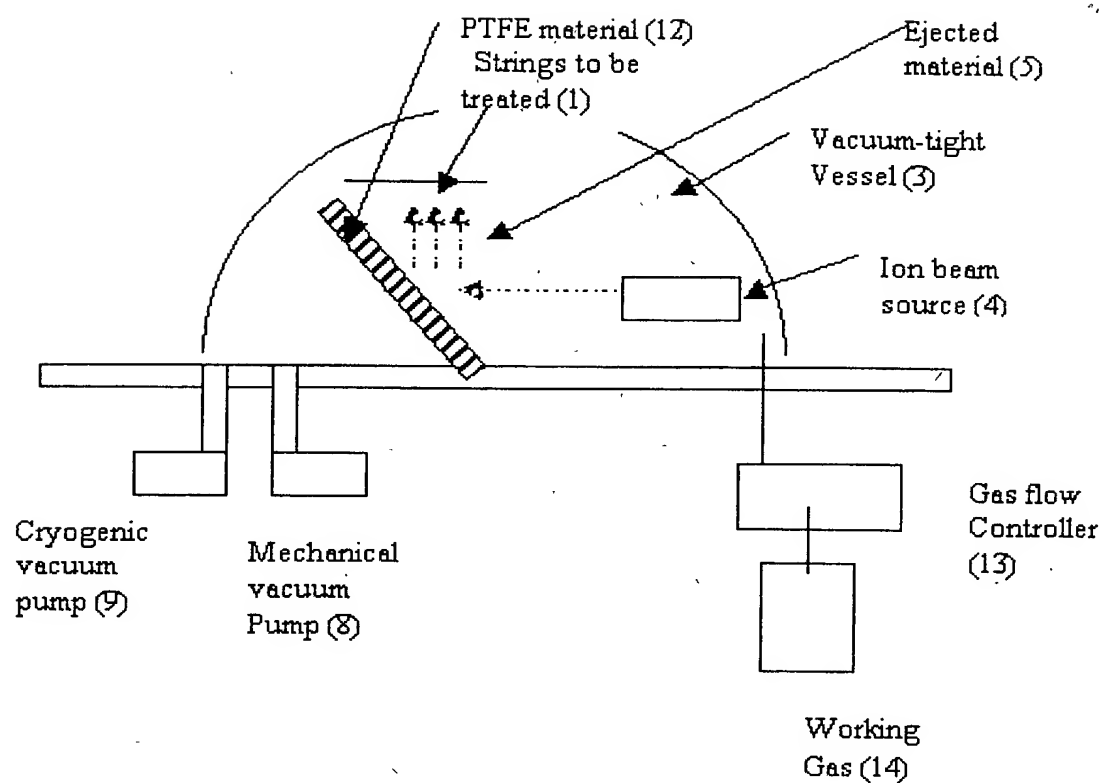


FIG 2: ION BEAM DEPOSITION SYSTEM

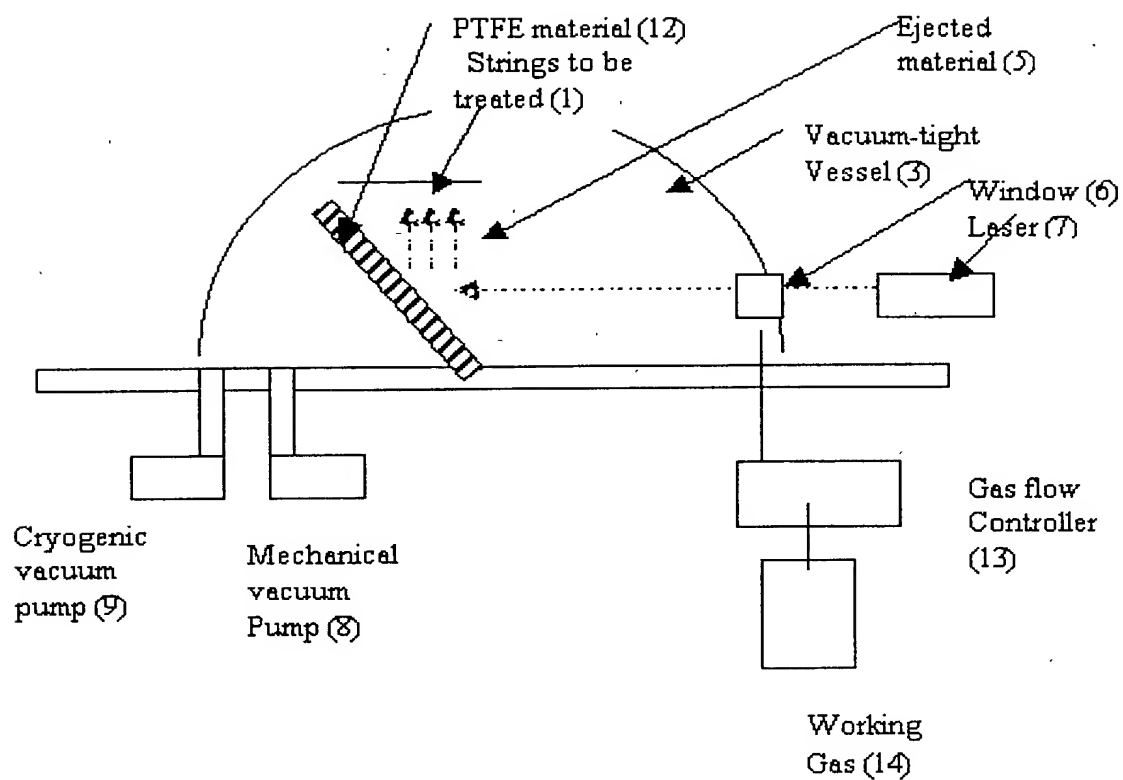


FIG 3: LASER DEPOSITION SYSTEM

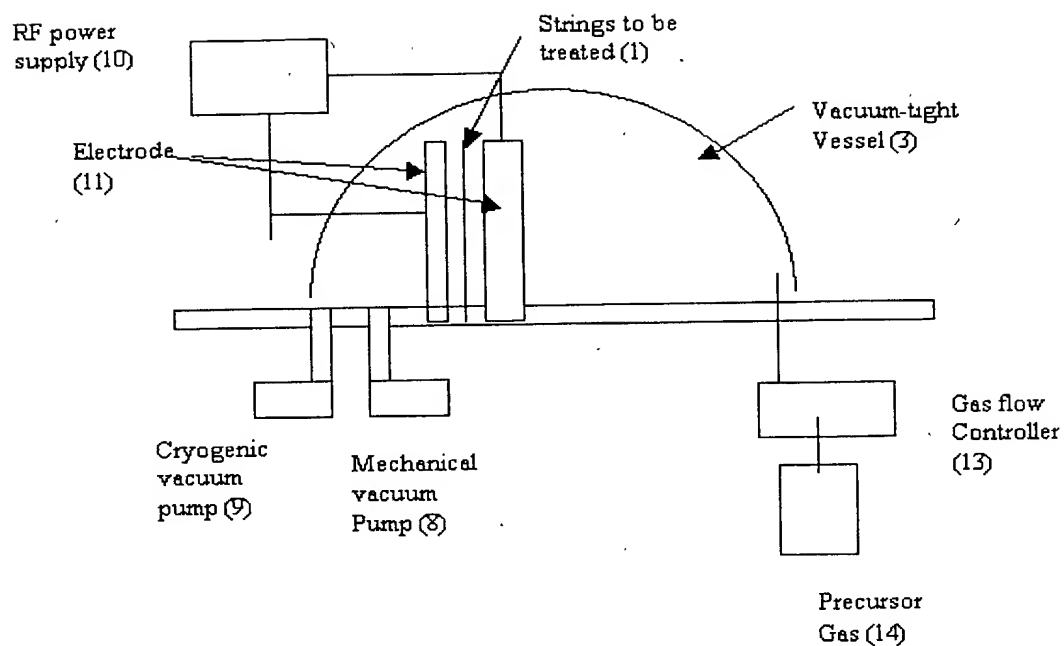


FIG 4: PLASMA CHEMICAL VAPOR DEPOSITION SYSTEM

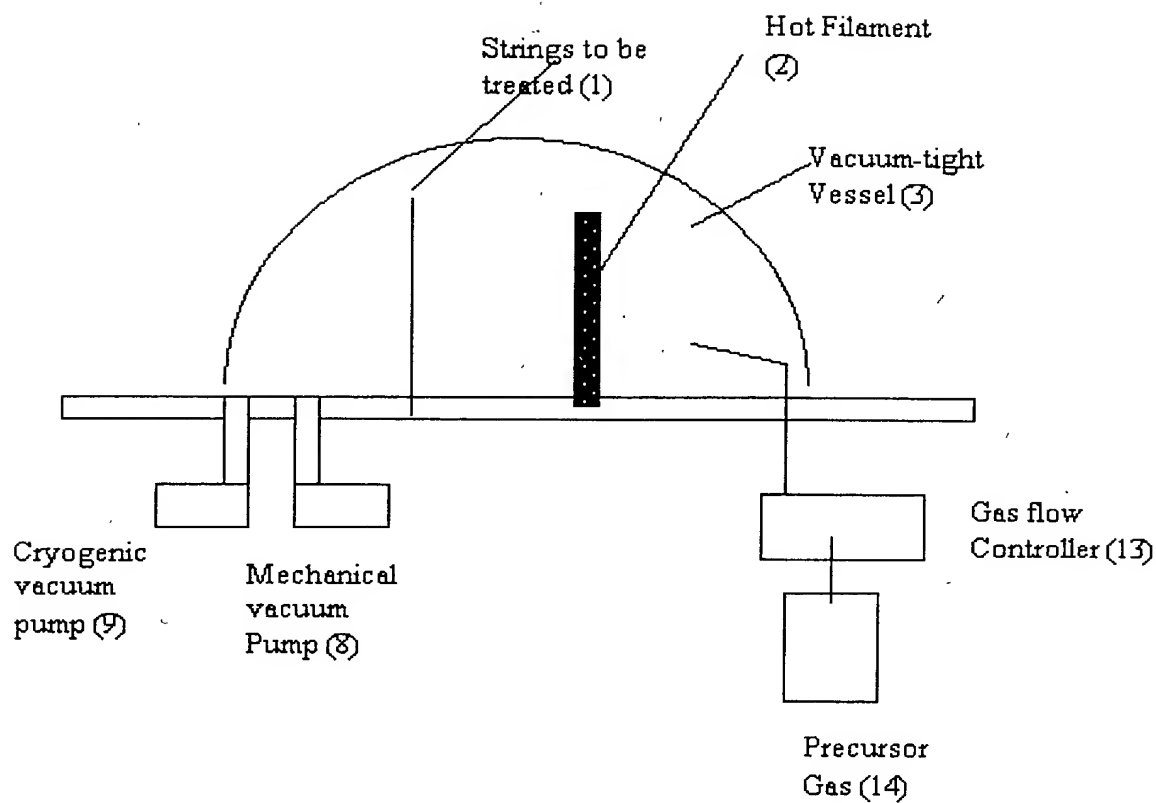


FIG 5: HOT FILAMENT CHEMICAL VAPOR DEPOSITION SYSTEM

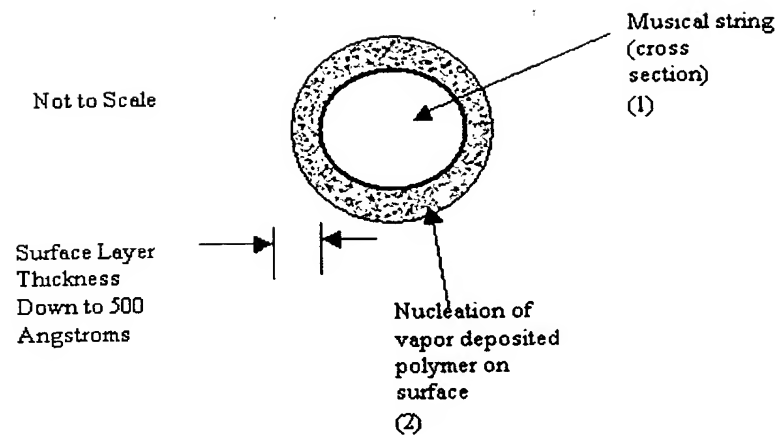
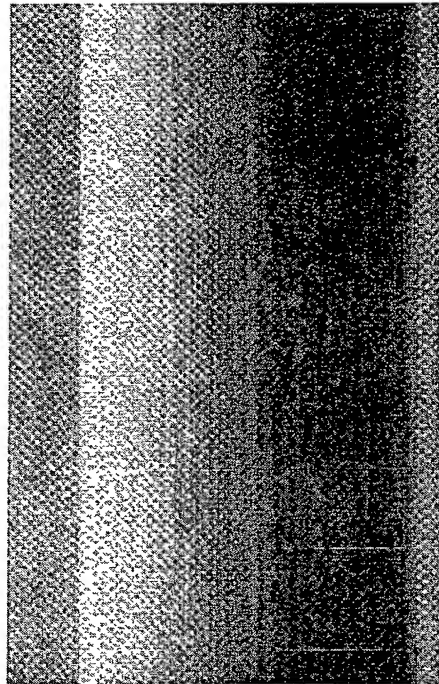
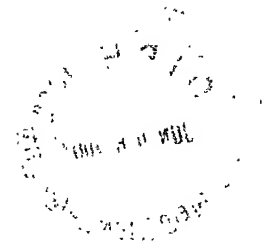


FIGURE 6: MUSICAL STRING TREATED  
WITH VAPOR DEPOSITED POLYMER

10002789.060602



*FIGURE 7*

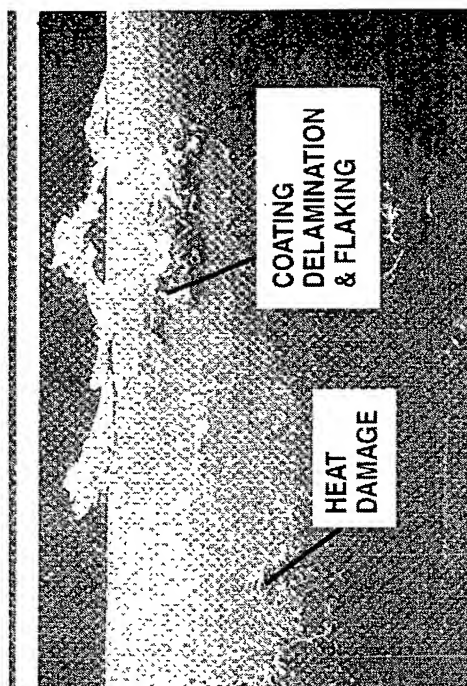


FIGURE 8



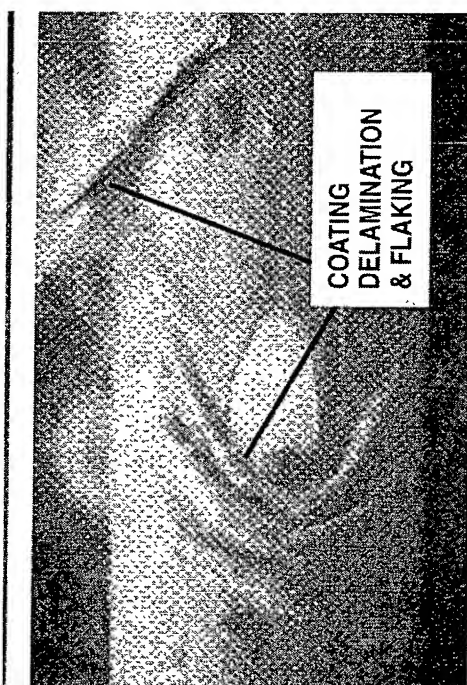
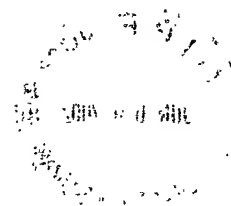


FIGURE 9